1 Mean, standard deviation, entropy maps of the patterns

1.1 Definitions

$$\bullet IQ_M = \frac{1}{W \cdot H} \sum_{i=1}^{W} \sum_{j=1}^{H} I_{ij}$$

- \diamond W: Pattern width
- \diamond H: Pattern height
- \diamond I_{ij} : Intensity (0-255) of the pixel at row i and column j

•
$$IQ_{\sigma} = \sqrt{\frac{\sum\limits_{i=1}^{W}\sum\limits_{j=1}^{H}I_{ij} - \bar{I}}{W \cdot H - 1}}$$

- \diamond W: Pattern width
- ♦ H: Pattern height
- \diamond I_{ij} : Intensity (0-255) of the pixel at row i and column j
- \diamond \bar{I} : Average intensity (i.e. IQ_M)

$$\bullet \ IQ_E = -\sum_{i=0}^{255} P_i \ln P_i$$

 $\diamond P_i$: Probability of gray level i

1.2 Advantages

- Less noise than IQ [3]
- Show micro-twins and scratches [3]
- Show small topography changes [3]
- Show strain levels [3]
- Don't rely on the detection of Kikuchi bands [3]
- Entropy maps have similar results than IQ [3]
- More related to surface topography [5]
- IQ_M very similar to FSD images (but with inverted contrast [5]
- IQ_M is mostly a measured of the overall backscatter yield (good for phase differentiation) [5]

1.3 Disadvantages

- Deteriorate with time due to contamination [3]
- Affected by gain and contrast settings of the EBSD detector unit as well as the SEM [5]
- Normalization is done using the hypothesis that the sum of all pixels in one row is constant [3]

1.4 Representation

• Black is assigned to all values less than 3σ and white to all values greater than 3σ [5]

2 Image Quality

2.1 Definitions

•
$$IQ_{HT} = \frac{1}{N} \sum_{i=1}^{N} H(\rho_i, \theta_i)$$

- \diamond N: number of peaks detected by the Hough transform (user defined value)
- $\Leftrightarrow H(\rho_i, \theta_i)$: Height of the ith peak
- \diamond IQ_{HT} will be dependent on the user's selection. Because the peaks are found in decreasing order of intensity, if fewer peaks are allowed, IQ_{HT} will be large.
- Normalization

$$\diamond\ IQ_{
m normalized} = rac{IQ_{
m initial}}{IQ_{
m standard}}$$

*
$$IQ_{\text{standard}}$$
: Average IQ value of a standard sample (no deformation)

$$\diamond \ IQ_{\rm normalized} = \frac{IQ_{\rm initial} - IQ_{\rm min}}{IQ_{\rm max} - IQ_{\rm min}}$$

- * IQ_{\min} : Minimum IQ value of a set
- * IQ_{max} : Maximum IQ value of a set

2.2 Factors

- Elastic strain [5]
 - \diamond "Bend" strain \rightarrow More diffuse bands
 - \diamond "Stretch" strain \rightarrow Wider bands
- Plastic strain [5]
 - \diamond Superposition of individual patterns \rightarrow More diffuse patterns
- Composition [5]
 - ♦ Heavier atoms have higher atomic scattering factors (brighter patterns)
- Surface topology [5]

2.3 Advantages

- Similar to confidence index [3]
- Metric describing the quality of a diffraction pattern [5]
- Doesn't show charge buildup (horizontal artifacts) like the mean, standard dev. and entropy does [5]
- Show boundaries (grain and phase) [5]
- Best map to differentiate between phases, grain boundaries and strain [5]
- Best contrast between strain and unstrained regions [5]
- IQ differences arising from orientation differences are generally mush smaller than those due to phase, grain boundaries or strain [5]
- Normalization minimized the effect of image processing on the IQ values [6]

2.4 Disadvantages

- Rely on the detection of Kikuchi bands (influence by false peaks) [3]
- Affected by various operator-defined parameters used in the calculation of the Hough transform [5]
- No distinction between high and low angles grain boundaries [5]
- IQ values are not corrected for the grain boundary contribution [6]
 - $\diamond\,$ Pixels around grain boundary should be removed from the IQ value

3 Image Quality in INCA Crystal

3.1 Definitions

- From [2]
- For each pattern, the 7 strongest Hough peaks are identified
- $IQ = 256 \frac{I_{\text{Max}} I_{\text{Min}}}{20000}$ (for 8 bit)
- $IQ = \frac{I_{\text{Max}} I_{\text{Min}}}{2000} 20 \text{ (for 16 bit)}$
 - $\diamond~I_{\rm Max} :$ Strongest peak relative to the average gray level (128) in Hough space
 - \diamond $I_{\rm Min}$: Smallest peak relative to the average gray level (128) in Hough space
- - \diamond For a standard deviation ranging from 4 to 13.5

4 Multi-peaks Model

4.1 Definitions

- From [6]
- $N = \sum_{i=1}^{k} n_i$
- $IQ \approx \sum_{i=1}^{k} ND(n_i, \mu_i, \sigma_i)$
 - \diamond N: Number of the total scan points in a file
 - \diamond k: Number of normal distributions in the simulation
 - \diamond ND: Normal distribution
- Conditions
 - 1. Min(k)

2.
$$\left\| IQ - \sum_{i=1}^{k} ND(n_i, \mu_i, \sigma_i) \right\| \le \epsilon$$

 \diamond ϵ : Minimum acceptable error

4.2 Advantages

• Study of multi-component microstructures [6]

5 Fourier Transform

5.1 Definitions

- Contrast [4]
 - ♦ Root mean square intensity of averaged band profiles
 - ♦ One dimension profiles were taken normal to the band at 1 pixel intervals along the length and superimposed, resulting in a projection of the average profile of the band
 - Sands nearly parallel to the selected band do contribute peaks in the profile, which are broadened by the misalignment with the projection direction
 - ♦ These features can be removed from the projected intensity profile by using a suitable window or weighting function
 - \diamond Hanning function was used: $H(x) = \frac{1}{2}\cos(2\pi x/X)$
 - * x: Sample number
 - *X: Total number of samples in the profile
 - The central peak is emphasizes, while the outer regions regions of the profile are continuously attenuated
- Sharpness/Diffuseness [4]
 - ♦ In a good quality pattern, the edges involve rapid changes in intensity (high frequency are present)
 - ♦ In a degraded pattern, the gray level changes at the edges occur more graduaylly (high frequency attenuated)
 - ♦ The attenuation of high frequency components of Fourier transform of the enhanced images and of the averaged band profiles
 - \diamond Two methods
 - 1. Spectral first peak area (SFPA)
 - * Calculate the area under the first peak in the power spectrum obtained from the projected average intensity profile
 - * Apply the Hanning function to the profile prior to transformation in order to emphasize the central Kikuchi band and to reduce leakage encountered in the use of discrete Fourier analysis.
 - * Take the fraction between the area under the first peak and the total area of the spectrum (independent of pattern quality)
 - 2. Power spectra first moment (PSFM)
 - * Use to generate a single value quantifying the quality of Kikuchi band profiles
 - * As the method is highly sensitive to the position at which any one single profile is taken, the use of 2D Fourier analysis reduces this dependence on positions
 - * Integration of the 2D spectrum around circular paths at each radii allows average coefficients at each frequency to be determined
 - * Hanning function is used
 - * Take the fraction between the first moment by the area under the spectrum (independent of pattern contrast)

5.2 Factors

- Strain
 - ♦ Steady decrease in the high frequency Fourier components as strain increases
 - \diamond Diffuseness of EBSP patterns is observed to increase with plastic strain

5.3 Advantages

- Cold work reduces both contrast and sharpness [4]
- Tilt effect contrast, but not sharpness [4]

5.4 Disadvantages

- Measurements are dependent on the contamination [4]
- Sampling of several grains is essential to build a calibration curve [4]

6 Band Contrast

6.1 Definitions

• Jump in contrast between the edge of the band and the adjacent background [1]

6.2 Disadvantages

• Not sufficient to reliably capture the deformation gradients [1]

7 Misorientation Mapping

7.1 Definitions

- Method [1]
 - 1. Establish grains in microstructure
 - 2. Determine the reference pixel for every individual grain
 - ♦ Calculate the mis-orientation for all nine-pixels clusters within a given grain, disregarding boundary pixels
 - ♦ Choose the cluster with least mis-orientation as reference (minimum distortion)
 - 3. Calculate and map the mis-orientation
 - ⋄ For a given grain, calculate the mis-orientation between each pixel and the reference pixel
 - ♦ Map this mis-orientation for each pixel using a color table

7.2 Advantages

- Small mis-orientations represent small amount of intra-grain mis-orientation / lattice rotation and therefore large deformations [1]
- Scratches are visible [1]
- Show extent of deformation zone [1]
- Sensitive to deformation on a grain-by-grain basis [1]

7.3 Disadvantages

- Lack of connection to more quantitative measures of deformation such as strain, strain gradient or dislocation density [1]
- The choice of the reference mis-orientation can substantially affect the resulting map [1]
- Not accurate enough to measure elastic strain [1]

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